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APPLICATION NO.		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/734,642		12/15/2003	Erwin Van Zwet	081468-0307212	9080
909	7590	01/05/2006	EXAMINER		
		THROP SHAW PIT	NGUYEN, HUNG		
P.O. BOX I MCLEAN,		102		ART UNIT	PAPER NUMBER
				2851	
			DATE MAILED: 01/05/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)					
Office Action Commence	10/734,642	ZWET ET AL.					
Office Action Summary	Examiner	Art Unit					
	Hung Henry V. Nguyen	2851					
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the	correspondence address					
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DATE - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period was realized to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDON	ON. timely filed om the mailing date of this communication. NED (35 U.S.C. § 133).					
Status							
1) Responsive to communication(s) filed on 04 No.	ovember 2005.						
2a) This action is FINAL . 2b) ⊠ This	action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11,	453 O.G. 213.					
Disposition of Claims							
4) Claim(s) 1-24 is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.							
	6)⊠ Claim(s) <u>1-24</u> is/are rejected.						
7) Claim(s) is/are objected to.							
8) Claim(s) are subject to restriction and/or	r election requirement.						
Application Papers							
9) The specification is objected to by the Examine	r. ·						
10)⊠ The drawing(s) filed on 15 December 2003 is/a							
Applicant may not request that any objection to the	• • • • • • • • • • • • • • • • • • • •	• •					
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
The bath of declaration is objected to by the Ex	aminer. Note the attached Offic	the Action of Ionn P10-152.					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of:							
1.☐ Certified copies of the priority documents have been received.							
2. Certified copies of the priority documents have been received in Application No							
3. Copies of the certified copies of the prior	ity documents have been recei	ved in this National Stage					
application from the International Bureau	ı (PCT Rule 17.2(a)).						
* See the attached detailed Office action for a list	of the certified copies not receive	ved.					
Attachment(s)							
1) Notice of References Cited (PTO-892)	4) Interview Summa						
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) 	Paper No(s)/Mail 5) Notice of Informa	Date I Patent Application (PTO-152)					
Paper No(s)/Mail Date <u>11/4/05; 8/25/05</u> .	6)						

Application/Control Number: 10/734,642 Page 2

Art Unit: 2851

DETAILED ACTION

Prosecution Status

1. This action office is NON-Final rejection since the Examiner has applied new references to reject original claim 21.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 5, 11, 16-18, 22-24 are rejected under 35 U.S.C. 103(a) as being unpatentable over Takahashi (U.S.Pat. 5,610,683) in view of Hwang et al (U.S.Pat. 6,185,085).

With respect to claims 1, 5, 11, 16-18 and 22-24, Takahashi discloses a lithographic apparatus comprising substantially all of the limitations of the instant claims such as: an illumination system (3) for providing a beam of radiation on a flat article (wafer) on an article support (12) in a beam path of the beam of radiation (see figure1); an article handler (11-3, 11-4) to move the article (wafer) during placement of the article on or removal of the article from the article support. Takahashi does not expressly disclose the article handle having an electrode and a dielectric layer for forming an electrostatic clamp for electrostatically clamping the article as recited in the instant claims. It is however noticed that a use of an electrostatic holding apparatus for transporting and/or attracting and fixing a wafer by means of electrostatic force is well known per se. For example, Hwang et al (figures 1-3) discloses an electrostatic handler (20) for transporting a semiconductor wafer (26) between a staging area and a processing station (see

Art Unit: 2851

abstract). Hwang teaches the electrostatic handler (20) comprising two electrodes (42, 57) and a dielectric layer (44) for forming an electrostatic clamping for electrostatically clamping the article (26). In view of such teachings, it would have been obvious to one having ordinary skill in the art at the time the invention was made to combine the teachings of Takahashi and Hwang to obtain the invention as specified in the mentioned claims. It would have been obvious to a skilled artisan to employ the electrostatic handle as taught by Hwang into the lithographic apparatus of Takahashi for the purpose of moving the article/wafer during the placement of the article/wafer on or removal of the article/wafer from the article support as suggested by Hwang.

Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 4 and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Takahashi (U.S.Pat. 5,610,683) in view of Hwang et al (U.S.Pat. 6,185,085) in view of Blake et al (U.S.Pat. 5,436,790).

With respect to claims 4 and 21, Takahashi et al as modified by Hwang el al discloses substantially of the limitations of the instant claim as discussed except for a presence detector for detecting the presence of the article as recited in the instant claim. Blake et al discloses an electrostatic handler for handling an article and having a presence detector for detecting the presence of the article through a measured capacity formed on an electrode, and the dielectric

Art Unit: 2851

layer of the handler (see col.5, lines 42-58). It would have been obvious to one having ordinary skill in the art at the time the invention was made to combine the teachings of Takahashi, Hwang and Blake et al to obtain the invention as specified in claims 4 and 21 of the present invention. It would have been obvious to a skilled artisan to employ the presence detector as taught by Blake et al into the article handler of Takahashi as modified by Hwang for the purpose of detecting the presence of the article on the handler and thus the status of the handle can be determined.

6. Claims 2-3, 6-10, 12-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Takahashi (U.S.Pat. 5,610,683) in view of Hwang et al (U.S.Pat. 6,185,085) in view of Kitabayashi et al (U.S.Pat. 5,530,616).

With respect to claims 2-3, 6-10, 14, Takahashi as modified by Hwang et al discloses a lithographic apparatus comparing substantially all of the structures set forth in the instant claims except for the details of the article handler as recited in the instant claims. Kitabayashi et al teaches an electrostatic handler having all of the claimed limitations such as: an article handler (1) having at least three mutually distanced contact members (5) for contacting the articles (W), a dielectric layer (3) is provided with protrusions (5) to provided a gap between the dielectric layer (3) and the article (W) and the gap ranges between 0.1 and about 5 microns (see col.6, lines 33-35), the diameter of each of the protrusions is at most 3mm (see col.2, lines 43-44) and the electrostatic clamp is designed to provide a clamping pressure greater than about 1.10⁴ Pa (see col.6, lines 50-51). Kitabayashi further teaches a metal pad bonded to the electrode in order to form a terminal for wiring and connecting the electrode to a power source. It would have been

Art Unit: 2851

obvious to one having ordinary skill in the art at the time the invention was made to combine the teachings of Kitabayashi, Takahashi and Hwang, to obtain the invention as specified in the instant claims. It would have been obvious to a skilled artisan to modify the article handler of Takahashi and Hwang as taught by Kitabayashi for the purpose of providing a proper electrostatic clamping force for transporting the article.

As to claims 8-10, 12-13, and 15, Takahashi as modified by Hwang and Kitabayashi lacks to show the material of the dielectric being at least of SiO2 and SiN and the dielectric layer being less than 50 microns and a dielectric constant being greater than about 3, as well as, the metal pad formed of the electrode being an Al layer. Since it has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability of the intended use as a matter of obvious design choice. It would have been obvious to a skilled artisan at the time the invention was made to select thickness and material of the dielectric layer as specified in the instant claims for the purpose of providing a proper clamping pressure of the electrostatic handle.

Prior Art Made of Record

7. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Husain (U.S.Pat. 5,880,922); Mogi et al (U.S.Pat. 6,351,367) disclose electrostatic chucking devices for wafer transport and support. Collins et al (U.S.Pat. 5,315,473) teaches an electrostatic wafer transfer blade and Burkhart et al (U.S.Pat. 6,075,375) teaches article holders with sensors for detecting the presence and position of a wafer.

Application/Control Number: 10/734,642 Page 6

Art Unit: 2851

Response to Amendment/Argument

8. Applicant's amendment filed November 4, 2005 has been entered. Applicants have amended claims 1, 9 and 22 for overcoming the rejections under the applied references set forth in the previous office action. Applicant's arguments with respect to amended claims have been carefully considered but have been traversed in view of new ground of rejections as set forth above.

9. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Henry V. Nguyen whose telephone number is 571-272-2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

hvn 1/1/06 HENRY HUNG NGUYEN
PRIMARY EXAMINER

Application/Control Number: 10/734,642

Page 7

Art Unit: 2851